







## **REPLY UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 2157**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.:

09/842,596

Filed: April 25, 2001

Inventors:

Sunil Shanthaveeraiah

Aseem Rastogi Raghavendra Rao

Title:

Persistent Repository for

On-Demand Node Creation

for Fabric Devices

Examiner:

Nano, Sargon N.

Group/Art Unit:

2157

Atty. Dkt. No:

5181-79300

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

Robert C. Kowert

Name of Registered Representative

July 27, 2005

Date

## RESPONSE TO FINAL ACTION OF MAY 31, 2005

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This paper is submitted in response to the Final Action of May 31, 2005, to further highlight why the application is in condition for allowance.